Radiopurity control in the NEXT-100 double beta decay experiment

- ✓ **NEXT experiment**
- ✓ Techniques and equipment
- ✓ Measurements and results
 - Shielding
 - Vessel
 - Electroluminescence (EL) and HV components
 - Tracking readout plane
 - Energy readout plane
- ✓ Summary and outlook



S. Cebrián

(on behalf of NEXT Collaboration and LSC Radiopurity Service)





NEXT: <u>Neutrino Experiment with a Xenon</u> <u>Time-Projection Chamber</u>

Goal and principle of detection

- Search for $\beta\beta$ of ¹³⁶Xe (Q=2.458 MeV) with ~100 kg at Canfranc Underground Laboratory (LSC) in Spain
- Challenge: measurement of topological signature
 - + optimization of energy resolution
 - + detector = source approach
- **Design:** high pressure gaseous xenon TPC with proportional

electroluminescent (EL) amplification



NEXT-100 Technical Design Report (TDR). Executive Summary, V. Alvarez et al, 2012 JINST 7 T06001

NEXT: <u>Neutrino Experiment with a Xenon</u> <u>Time-Projection Chamber</u>

- Sensitivity and background requirements
 - Energy resolution: <1% FWHM at Q_{ββ}
 - \rightarrow electroluminiscence
 - Background level: 8 10⁻⁴ c keV⁻¹ kg⁻¹ y⁻¹
 - → pattern recognition + radiopurity control ²⁰⁸TI: 2.615 MeV ²¹⁴Bi: 2.448 MeV

Status

Near-Intrinsic Energy Resolution for 30 to 662 keV Gamma Rays in a High Pressure Xenon Electroluminescent TPC, V. Alvarez et al, NIMA 708 (2013) 101-114 Initial results of NEXT-DEMO, a large-scale prototype of the NEXT-100 experiment V. Alvarez et al, JINST 8 (2013) P04002

- Installation of shielding and ancillary system started at LSC
- Assembly and comissioning of detector expected for 2014





NEXT: <u>Neutrino Experiment with a Xenon</u> <u>Time-Projection Chamber</u>

Status





¹³⁷Cs reconstructed track from

next

Fig. 13. Energy resolution at 10 atm for 662 keV gamma rays: These data were taken at 10.1 atm with a 0.16 kV/cm field in the drift region and 2.08 kV/(cm atm) in the EL region. If assumed to follow a $1/\sqrt{N}$ dependence this resolution extrapolates to 0.57% at $Q_{\beta\beta} = 2.459$ MeV.

tion NEXT-DEMO

¹³⁷Cs spectrum from NEXT-DMDB

Near-Intrinsic Energy Resolution for 30 to 662 keV Gamma Rays in a High Pressure Xenon Electroluminescent TPC, V. Alvarez et al, NIMA 708 (2013) 101-114

Techniques and equipment

Glow Discharge Mass Spectrometry (GDMS)

- Performed by Shiva Technologies (Evans Analytical Group) in France
- Used for several metal samples
- Output: U, Th, K concentrations

Ge gamma-ray spectrometry

- Several p-type closed-end coaxial **HPGe detectors** of LSC Radiopurity Service

	Detectors	DAQ	Shielding	Operation
LSC Radiopurity Service: GeOroel GeAnayet GeTobazo GeLatuca	410-420 cm ³ Al cryostats	Canberra DSA 1000 modules	5 cm Cu + 20 cm low activity Pb flux of N_2 gas	Hall C, since 2011
U. Zaragoza: Paquito	190 cm ³ Cu cryostat	standard Canberra LA + ADC	10 cm arch. Pb + 15 cm low activity Pb flux of N_2 gas	Canfranc old facilities for several years, now at Hall C



Techniques and equipment

Ge gamma-ray spectrometry

Background counting rates: c d⁻¹kg⁻¹

		_	²⁰² I N. ²⁰⁰ I I	2000:217BI	٦°۲
Detector name	Mass (kg)	100–2700 keV	583 keV	609 keV	1461 keV
GeOroel	2.230	490±2	$0.8 {\pm} 0.1$	3.0 ± 0.2	$0.41 {\pm} 0.07$
GeAnayet	2.183	714±3	$3.8 {\pm} 0.2$	$1.7{\pm}0.1$	$0.38{\pm}0.07$
GeTobazo	2.185	708 ± 3	$4.0 {\pm} 0.2$	1.3 ± 0.1	$0.40{\pm}0.06$
GeLatuca	2.187	710±3	$3.3 {\pm} 0.2$	$5.9 {\pm} 0.3$	$0.56{\pm}0.08$
Paquito	1	79 ± 2	$0.27 {\pm} 0.09$	$0.5 {\pm} 0.1$	$0.25{\pm}0.09$

200

2201 1 24 / m

101/



S. Cebrián, LRT2013 Workshop, LNGS 10-12 April 2013

Techniques and equipment

Ge gamma-ray spectrometry

- Detection efficiency
 - Evaluated for each sample using GEANT4 simulations
 - Simulation environment validated by comparing with the measured efficiency curve using a reference ¹⁵²Eu source at 25 cm





Overall uncertainty of 10% is considered for the simulated detection efficiency

Radiopurity control in the NEXT-100 double beta decay experiment





S. Cebrián

(on behalf of NEXT Collaboration and LSC Radiopurity Service)



Universidad

Zaragoza

Measurements and results

Material, Supplier	# in table 3	Detector	Sample size	Screening
				time (d)
Pb, Tecnibusa	5	GeAnayet	5585 g	19.44
Pb, Tecnibusa	6	GeAnayet	5585 g	35.99
Cu, Luvata	10	Paquito	681 g	39.17
Ti, SMP	11	GeOroel	121 g	38.46
Ti, SMP	12	GeTobazo	121 g	43.11
Ti, Ti Metal Supply	13	GeOroel	1804 g	47.23
304L Stainless Steel, Pfeiffer	14	Paquito	347 g	19.55
316Ti Stainless Steel, 10 mm, Nironit	15	GeTobazo	7684 g	33.00
316Ti Stainless Steel, 15 mm, Nironit	16	GeTobazo	10205 g	35.61
316Ti Stainless Steel, 50 mm, Nironit	17	GeAnayet	4816 g	34.72
Inconel 625, Mecanizados Kanter	18	GeTobazo	1004 g	27.98
Inconel 718, Mecanizados Kanter	19	GeOroel	611 g	27.93
PEEK, Sanmetal	20	Paquito	459 g	24.27
Polyethylene, IN2 Plastics	21	GeAnayet	1315 g	36.76
Semitron ES225, Quadrant EPP	22	GeOroel	1618 g	35.05
SMD resistor, Farnell	23	Paquito	50 pc	18.15
SM5D resistor, Finechem	24	Paquito	100 pc	31.45
Kapton-Cu PCB, LabCircuits	25	Paquito	260.15 cm^2	35.28
Cuflon, Polyflon	26	GeOroel	1876 g	24.29
Bonding films, Polyflon	27	GeAnayet	288 g	30.83
FFC/FCP connector, Hirose	28	Paquito	19 pc (1.23 g/pc)	6.83
P5K connector, Panasonic	29	Paquito	15 pc (0.67 g/pc)	7.58
Thermoplastic connector, Molex	30	GeLatuca	29 pc (0.53 g/pc)	17.20
Solder paste, Multicore	31	GeLatuca	457 g	44.30
Solder wire, Multicore	32	Paquito	91 g	7.74
Ta capacitor, Vishay Sprague	33	GeAnayet	277 pc (0.64 g/pc)	17.97

> New measurements:

Material, Supplier	Detector	Sample size	Screening time (d)
TIG-MIG welding on Nironit 316Ti stainless steel, Movesa	GeLatuca	1048.1 g	48.93
Kynar (=PVDF), Boedeker	GeLatuca	1870.3 g	51.55
Tefzel (=ETFE) HV feedtrough	GeTobazo	239.7 g	43.89
Dice Boards , Pyrecap	GeOroel	140 g	45.11
Sapphire , Precision Sapphire Technologies	GeAnayet	526.6 g	44.94
PMT , Hamamatsu R11410MOD	GeAnayet	1 unit	33.70

Radiopurity control in the NEXT-100 double beta decay experiment: procedures and initial measurements V. Alvarez et al, 2013 JINST 8 T01002

Results: shielding

Passive shield:

- External 20-cm-thick Pb
- Internal 12-cm-thick Cu



#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	Shielding											
1	Pb	Cometa	GDMS	mBq/kg	0.37		0.073			< 0.31		
2	Pb	Mifer	GDMS	mBq/kg	<1.2		< 0.41			0.31		
3	Pb	Mifer	GDMS	mBq/kg	0.33		0.10			1.2		
4	Pb	Tecnibusa	GDMS	mBq/kg	0.73		0.14			0.91		
5	Pb	Tecnibusa	Ge	mBq/kg	<94	<2.0	<3.8	<4.4	<30	<2.8	< 0.2	$<\!\!0.8$
6	Pb	Tecnibusa	Ge	mBq/kg	<57	<1.9	<1.7	<2.8	<22	<1.7	< 0.1	< 0.5
7	Cu (ETP)	Sanmetal	GDMS	mBq/kg	< 0.062		< 0.020				-	
8	Cu (C10100)	Luvata (hot rolled)	GDMS	mBq/kg	< 0.012		< 0.0041			0.061		
9	Cu (C10100)	Luvata (cold rolled)	GDMS	mBq/kg	< 0.012		< 0.0041			0.091		
10	Cu (C10100)	Luvata (hot+cold rolled)	Ge	mBq/kg		<7.4	< 0.8	<4.3		<18	$<\!0.8$	<1.2

Results: vessel

Pressure vesel:

• To hold 15 b, diameter 1.4 m, length 2.3 m

- Cylindrical center section + two torispherical heads on each end
- Made of stainless steel, even if first option was titanium



#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	Vessel											
11	Ti	SMP	Ge	mBq/kg	<233	<5.7	<8.8	<9.5	$3.4{\pm}1.0$	<22	<3.3	<5.2
12	Ti	SMP	Ge	mBq/kg	<361	<6.6	<11	< 10	$<\!\!8.0$	<15	< 1.0	<1.8
13	Ti	Ti Metal Supply	Ge	mBq/kg	<14	< 0.22	< 0.5	3.6 ± 0.2	$0.43 {\pm} 0.08$	$<\!0.6$	< 0.07	< 0.07
14	304L SS	Pfeiffer	Ge	mBq/kg		14.3 ± 2.8	9.7 ± 2.3	16.2 ± 3.9	3.2 ± 1.1	<17	11.3 ± 2.7	<1.6
15	316Ti SS	Nironit, 10-mm-thick	Ge	mBq/kg	<21	< 0.57	< 0.59	< 0.54	< 0.74	< 0.96	2.8 ± 0.2	< 0.12
16	316Ti SS	Nironit, 15-mm-thick	Ge	mBq/kg	<25	$<\!0.46$	< 0.69	< 0.88	< 0.75	< 1.0	4.4 ± 0.3	< 0.17
17	316Ti SS	Nironit, 50-mm-thick	Ge	mBq/kg	67 ± 22	<1.7	2.1 ± 0.4	2.0 ± 0.7	$2.4{\pm}0.6$	<2.5	4.2 ± 0.3	< 0.6
18	Inconel 625	Mecanizados Kanter	Ge	mBq/kg	<120	<1.9	<3.4	<3.2	<4.6	<3.9	< 0.4	< 0.6
19	Inconel 718	Mecanizados Kanter	Ge	mBq/kg	309 ± 78	<3.4	<5.1	<4.4	15.0 ± 1.9	<13	<1.4	<1.3





Results: vessel

#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	Vessel											
11	Ti	SMP	Ge	mBq/kg	<233	<5.7	<8.8	<9.5	$3.4{\pm}1.0$	<22	<3.3	<5.2
12	Ti	SMP	Ge	mBq/kg	<361	<6.6	<11	<10	$<\!\!8.0$	<15	< 1.0	<1.8
13	Ti	Ti Metal Supply	Ge	mBq/kg	<14	< 0.22	< 0.5	3.6 ± 0.2	$0.43 {\pm} 0.08$	$<\!0.6$	< 0.07	< 0.07
14	304L SS	Pfeiffer	Ge	mBq/kg		14.3 ± 2.8	9.7 ± 2.3	16.2 ± 3.9	$3.2{\pm}1.1$	<17	11.3 ± 2.7	<1.6
15	316Ti SS	Nironit, 10-mm-thick	Ge	mBq/kg	<21	< 0.57	< 0.59	< 0.54	< 0.74	< 0.96	2.8 ± 0.2	< 0.12
16	316Ti SS	Nironit, 15-mm-thick	Ge	mBq/kg	<25	< 0.46	< 0.69	< 0.88	< 0.75	< 1.0	4.4 ± 0.3	< 0.17
17	316Ti SS	Nironit, 50-mm-thick	Ge	mBq/kg	67 ± 22	<1.7	2.1 ± 0.4	2.0 ± 0.7	$2.4{\pm}0.6$	<2.5	4.2 ± 0.3	< 0.6
18	Inconel 625	Mecanizados Kanter	Ge	mBq/kg	<120	<1.9	<3.4	<3.2	<4.6	<3.9	< 0.4	< 0.6
19	Inconel 718	Mecanizados Kanter	Ge	mBq/kg	309 ± 78	<3.4	<5.1	<4.4	15.0 ± 1.9	<13	<1.4	<1.3









> New measurements:

Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
TIG-MIG welding on 316Ti SS	Nironit (SS), Movesa	Ge	mBq/cm	< 7.3	< 0.11	< 0.32	< 0.21		0.86 ± 0.14		

Results: EL & HV components

Field cage:

- Using copper rings connected to resistors and HD polyethylene as insulator
- Wire meshes separating the different field regions will be made of stainless steel

Reflector panels:

- Made of PTFE Tetratex fixed over a 3M substrate
- Coated with a wavelength shifter (TPB)

#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	HV, EL components											
20	PEEK	Sanmetal	Ge	mBq/kg		36.3±4.3	14.9 ± 5.3	11.0 ± 2.4	<7.8	8.3 ± 3.0	<3.3	<2.6
21	Polyethylene	IN2 Plastics	Ge	mBq/kg	<140	<1.9	<3.8	<2.7	<1.0	<8.9	< 0.5	< 0.5
22	Semitron ES225	Quadrant EPP	Ge	mBq/kg	<101	<2.3	<2.0	<1.8	1.8 ± 0.3	513 ± 52	< 0.5	< 0.6
23	SMD resistor	Farnell	Ge	mBq/pc	2.3±1.0	$0.16 {\pm} 0.03$	$0.30 {\pm} 0.06$	$0.30 {\pm} 0.05$	< 0.05	$0.19 {\pm} 0.08$	< 0.02	< 0.03
24	SM5D resistor	Finechem	Ge	mBq/pc	$0.4{\pm}0.2$	0.022 ± 0.007	< 0.023	< 0.016	0.012 ± 0.005	0.17 ± 0.07	< 0.005	< 0.005



Results: EL & HV components

#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	HV, EL components											
20	PEEK	Sanmetal	Ge	mBa/kg		363+43	14 9+5 3	11.0+2.4	<7.8	83+30	<33	<26
21	Polyethylene	IN2 Plastics	Ge	mBq/kg	<140	<1.9	<3.8	<2.7	<1.0	<8.9	< 0.5	< 0.5
22	Semitron ES225	Quadrant EPP	Ge	mBq/kg	<101	<2.3	<2.0	< 1.8	1.8 ± 0.3	513 ± 52	< 0.5	< 0.6
23	SMD resistor	Farnell	Ge	mBq/pc	2.3 ± 1.0	0.16 ± 0.03	$0.30 {\pm} 0.06$	0.30 ± 0.05	< 0.05	$0.19{\pm}0.08$	< 0.02	< 0.03
24	SM5D resistor	Finechem	Ge	mBq/pc	$0.4{\pm}0.2$	$0.022 {\pm} 0.007$	< 0.023	< 0.016	$0.012 {\pm} 0.005$	$0.17 {\pm} 0.07$	< 0.005	< 0.005

> New measurements:

Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
Kynar=PVDF	Boedeker	Ge	mBq/kg	< 96	< 1.4	< 2.7	< 1.8	<0.68	41.5 ± 4.6	< 0.29	< 0.35
Tefzel (=ETFE) HV feedtrough		Ge	mBq/kg	< 566	< 5.7	< 14	< 9.2	< 3.6	< 30	< 1.2	< 1.7



Results: tracking readout

Tracking readout plane:

Array of 110 "Dice Boards" (DB), behind the EL region
Each DB contains 8x8 SiPM sensors with a pitch of ~1 cm and is coated with TPB



#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	Energy, tracking planes											
25	Kapton-Cu PCB	LabCircuits	Ge	mBq/cm ²	< 0.26	< 0.014	< 0.012	< 0.008	< 0.002	< 0.040	< 0.002	< 0.002
26	Cuflon	Polyflon	Ge	mBq/kg	<33	<1.3	<1.1	<1.1	$<\!0.6$	4.8 ± 1.1	< 0.3	< 0.3
27	Bonding films	Polyflon	Ge	mBq/kg	1140 ± 300	487±23	$79.8 {\pm} 6.6$	66.0 ± 4.8	60.0 ± 5.5	832 ± 87	<4.4	<3.8
28	FFC/FCP connector	Hirose	Ge	mBq/pc	<50	4.6 ± 0.7	6.5 ± 1.2	$6.4{\pm}1.0$	<0.75	$3.9{\pm}1.4$	< 0.2	< 0.5
29	P5K connector	Panasonic	Ge	mBq/pc	<42	6.0 ± 0.9	9.5 ± 1.7	$9.4{\pm}1.4$	< 0.95	4.1 ± 1.5	< 0.2	$<\!0.8$
30	Thermopl. connector	Molex	Ge	mBq/pc	<7.3	$1.77 {\pm} 0.08$	3.01 ± 0.19	2.82 ± 0.15	< 0.31	2.12 ± 0.25	< 0.022	$0.27 {\pm} 0.03$
31	Solder paste	Multicore	Ge	mBq/kg	<310	<4.9	$<\!8.0$	<6.0	<5.2	<13	< 1.0	<1.6
32	Solder wire	Multicore	Ge	mBq/kg	$<\!\!4900$	$(7.7 \pm 1.2)10^2$	<147	<14		<257	<30	<36
33	Ta capacitor	Vishay Sprague	Ge	mBq/pc	$<\!0.8$	$0.043 {\pm} 0.003$	$0.034{\pm}0.004$	$0.032{\pm}0.003$	< 0.010		< 0.002	< 0.003



Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
Dice Boards	Pyrecap	Ge	mBq/DB	< 7.6	0.28±0.08	< 0.28	< 0.25	< 0.13	< 1.2	< 0.07	< 0.06

Results: tracking readout

#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	Energy, tracking planes											
25	Kapton-Cu PCB	LabCircuits	Ge	mBq/cm ²	< 0.26	< 0.014	< 0.012	< 0.008	< 0.002	< 0.040	< 0.002	< 0.002
26	Cuflon	Polyflon	Ge	mBq/kg	<33	<1.3	<1.1	<1.1	$<\!0.6$	4.8 ± 1.1	< 0.3	< 0.3
27	Bonding films	Polyflon	Ge	mBa/ko	1140 ± 300	487 + 23	79.8 ± 6.6	66.0 ± 4.8	60.0 ± 5.5	832 + 87	< 4.4	<3.8
28	FFC/FCP connector	Hirose	Ge	mBq/pc	< 50	4.6 ± 0.7	6.5 ± 1.2	$6.4{\pm}1.0$	< 0.75	$3.9{\pm}1.4$	< 0.2	< 0.5
29	P5K connector	Panasonic	Ge	mBq/pc	<42	6.0 ± 0.9	9.5 ± 1.7	$9.4{\pm}1.4$	< 0.95	4.1 ± 1.5	< 0.2	< 0.8
30	Thermopl_connector	Molex	Ge	mBq/pc	<7.3	1.77 ± 0.08	3.01 ± 0.19	2.82 ± 0.15	< 0.31	2.12 ± 0.25	< 0.022	0.27 ± 0.03
31	Solder paste	Multicore	Ge	mBq/kg	<310	<4.9	$<\!\!8.0$	$<\!\!6.0$	<5.2	<13	< 1.0	<1.6
32	Solder wire	Multicore	Ge	mBq/kg	$<\!\!4900$	$(7.7 \pm 1.2)10^2$	<147	<14		<257	<30	<36
33	Ta capacitor	Vishay Sprague	Ge	mBq/pc	< 0.8	0.043 ± 0.003	0.034 ± 0.004	0.032 ± 0.003	< 0.010		< 0.002	< 0.003





Results: tracking readout

#	Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
	Energy, tracking planes											
25	Kapton-Cu PCB	LabCircuits	Ge	mBq/cm ²	< 0.26	< 0.014	< 0.012	< 0.008	< 0.002	< 0.040	< 0.002	< 0.002
26	Cuflon	Polyflon	Ge	mBq/kg	<33	<1.3	<1.1	<1.1	< 0.6	4.8 ± 1.1	< 0.3	< 0.3
27	Bonding films	Polyflon	Ge	mBq/kg	1140 ± 300	487 ± 23	$79.8 {\pm} 6.6$	66.0 ± 4.8	60.0 ± 5.5	832 ± 87	<4.4	<3.8
28	FFC/FCP connector	Hirose	Ge	mBq/pc	<50	4.6 ± 0.7	6.5 ± 1.2	6.4 ± 1.0	< 0.75	$3.9{\pm}1.4$	< 0.2	< 0.5
29	P5K connector	Panasonic	Ge	mBq/pc	<42	$6.0 {\pm} 0.9$	9.5 ± 1.7	$9.4{\pm}1.4$	< 0.95	4.1 ± 1.5	< 0.2	$<\!0.8$
30	Thermopl. connector	Molex	Ge	mBq/pc	<7.3	$1.77 {\pm} 0.08$	3.01 ± 0.19	$2.82{\pm}0.15$	< 0.31	2.12 ± 0.25	< 0.022	$0.27 {\pm} 0.03$
31	Solder paste	Multicore	Ge	mBq/kg	<310	<4.9	$<\!\!8.0$	<6.0	<5.2	<13	< 1.0	<1.6
32	Solder wire	Multicore	Ge	mBq/kg	<4900	$(7.7\pm1.2)10^2$	<147	<14		<257	<30	<36
33	Ta capacitor	Vishay Sprague	Ge	mBq/pc	< 0.8	0.043 ± 0.003	$0.034{\pm}0.004$	$0.032{\pm}0.003$	< 0.010		< 0.002	< 0.003

Future measurements:

- Final DB including TPB coating
- Flat cables
- NTC sensors



Results: energy readout

Energy readout plane:

• Array of 60 Hamamatsu R11410MOD PMTs behind the cathode to detect EL light and primary scintillation light

• Each PMT sealed into individual, pressure resistant Cu enclosures, coupled to the sensitive volume through a sapphire window coated with TPB.



Material	Supplier	Technique	Unit	²³⁸ U	²²⁶ Ra	²³² Th	²²⁸ Th	²³⁵ U	⁴⁰ K	⁶⁰ Co	¹³⁷ Cs
Sapphire windows	Precision Sapphire Technologies	Ge	mBq/kg	< 275	< 2.7	< 7.6	< 5.5	< 2.1	< 18	< 0.7	< 1.0
PMT R11410MOD	Hamamatsu	Ge	mBq/PMT	< 187	< 1.8	< 5.4	< 3.4	< 1.6	< 29	2.82 ± 0.27	< 0.6





PRELIMINARY!



Future measurements: - PMTs

- PMT bases, copper cans

Summary and outlook

✓ A thorough radiopurity control is being performed for the NEXT-100 ββ experiment, based on mainly **ultra-low background Ge** *γ*-ray spectrometry at LSC.

- Adequate materials for external and internal passive shields identified
- The good radiopurity found for the 316Ti stainless steel confirmed this material for the detector vessel
- Selection of in-vessel components for energy and tracking planes has been performed too, helping in the design of DB
 - Resistors, capacitors and solder paste of acceptable radiopurity found
 - Board-to-cable connectors containing LCP discarded
 - Cuflon, being radiopure enough, chosen for DB
- ✓ Further radiopurity measurements at LSC are scheduled.
 - Selection of photomultipliers of the chosen model
 - Screening of related components (bases and cans) at the energy plane